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501.33745CX4

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : MAEDA, et al.  
Serial No.: 10/686,584  
Filed: October 17, 2003  
For: MANUFACTURING METHOD OF SEMICONDUCTOR  
SUBSTRATE AND METHOD AND APPARATUS FOR  
INSPECTING DEFECTS OF PATTERNS OF AN OBJECT TO  
BE INSPECTED  
  
Group: 2877  
Examiner: H. Pham

**STATEMENT OF SUBSTANCE OF INTERVIEW**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 19, 2005

Sir:

The following statement of the substance of the personal interview conducted between the listed PTO personnel and the undersigned on September 13, 2005 is being submitted.

The Examiner's statement of the substance of the interview in the Interview Summary is complete and correct.

To the extent necessary, applicants petition for an extension of time under 37 CFR 1.136. Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli,

Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case No. 501.33745CX4),  
and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



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PJS/slk